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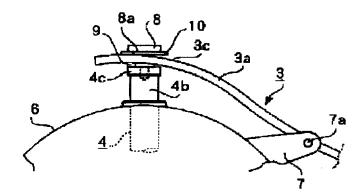
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TITLE

DISPLACEMENT MEASURING

APPARATUS



ABSTRACT :

PROBLEM TO BE SOLVED: To obtain a displacement measuring apparatus capable of nimble shift operation of a spindle with a lifting lever without being affected by the state of a contact surface of a stop screw and the state of an upper surface of the lifting lever.

SOLUTION: In this displacement measuring apparatus, a spindle 4 which gives the amount of displacement by being supported slidably to a displacement measuring main body 6 is subjected to forced shifting by a lifting lever 3 which is operated from the outside. In this case, a thin hard resin plate 10 is interposed between a contact surface 8a of an operation end portion 4b of the spindle 4 with which surface a driving end portion 3a of the lifting lever 3 comes into contact and the driving end portion 3a.

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